

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Lehman et al.

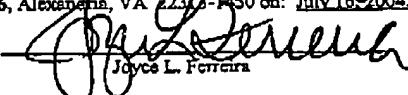
Attorney Docket No.:  
KLA1P015AD2/P611A2

Application No.: 10/623,953

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Filed: July 21, 2003

JUL 16 2004

Title: IN-SITU METALIZATION MONITORING  
USING EDDY CURRENT MEASUREMENTS  
DURING THE PROCESS FOR REMOVING THE  
FILMExaminer: Aurora, R.  
Group: 2862**OFFICIAL**CERTIFICATE OF FACSIMILE TRANSMISSION:  
I hereby certify that this correspondence is being transmitted by  
facsimile to the United States Patent and Trademark Office,  
Commissioner for Patents, Attn: Examiner Aurora, Fax No. 703-  
872-9306, Alexandria, VA 22313-1450 on: July 16-2004.Signed:   
Joyce L. Pereira**RESPONSE TO RESTRICTION REQUIREMENT**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated June 23, 2004, Applicant hereby elects, without traverse, group I claims 1 and 2, drawn to a method for measuring conductance of a sample and generating a lift off curve, to prosecute in the above-identified patent application.

If any fees are due in connection with the filing this Response to Restriction Requirement, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. KLA1P015AD2).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

Haruo Yawata

Limited Recognition under 37 C.F.R. §10.9(b)

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July 16, 2004

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**Sender:** Haruo Yawata  
**Our Ref. No.:** KLA1P015AD2

**Application No.:** 10/623,953

**Re:** Response to Restriction

**Pages Including Cover Sheet(s):** 03

**MESSAGE:**

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**BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE  
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**LIMITED RECOGNITION UNDER 37 CFR § 10.9(b)**

Mr. Haruo Yawata is hereby given limited recognition under 37 CFR § 10.9(b) as an employee of Beyer Weaver & Thomas, LLP to prepare and prosecute patent applications wherein the patent applicant is the client of Beyer Weaver & Thomas, LLP, and the attorney or agent of record in the applications is a registered practitioner who is a member of Beyer Weaver & Thomas, LLP. This limited recognition shall expire on the date appearing below, or when whichever of the following events first occurs prior to the date appearing below: (i) Mr. Haruo Yawata ceases to lawfully reside in the United States, (ii) Mr. Haruo Yawata's employment with Beyer Weaver & Thomas, LLP ceases or is terminated, or (iii) Mr. Haruo Yawata ceases to remain or reside in the United States on an H-1 visa.

This document constitutes proof of such recognition. The original of this document is on file in the Office of Enrollment and Discipline of the U.S. Patent and Trademark Office.

Expires: August 28, 2004

  
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Harry I. Moatz  
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